



Law

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kenichi WATANABE**

Group Art Unit: **2826**

Application Number: **10/622,614**

Examiner: **Alexander O. Williams**

Filed: **July 21, 2003**

Confirmation Number: **2630**

For: **SEMICONDUCTOR DEVICE FOR PREVENTING DEFECTIVE
FILLING OF INTERCONNECTION AND CRACKING OF
INSULATING FILM (AS AMENDED)**

Attorney Docket Number: **030877**

Customer Number: **38834**

REQUEST FOR RETURN OF PTO/SB/08

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

June 25, 2007

Sir:

Applicants filed an Information Disclosure Statement (IDS) on December 2, 2005. A copy of the IDS is attached hereto.

Applicants respectfully request that the Examiner return a copy of the Form PTO/SB/08 that accompanies the IDS, marked to indicate that the references listed therein have been considered by the Office.

The Examiner is encouraged to telephone the undersigned if the Examiner has any questions concerning this Request.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Sadao Kinashi

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SK/ar

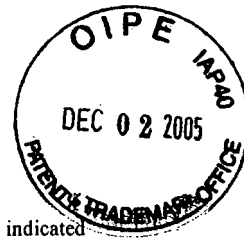


U.S. Patent Application
Serial No.: 10/622,614
Applicant: Kenichi WATANABE et al.

Docket No: 030877
Filed: July 21, 2003

Papers filed herewith on: **December 2, 2005**

Other: Petition for Withdrawal from Issue under 37 CFR 1.313(cc) (2);
Request for Continued Examination (RCE) Transmittal;
Information Disclosure Statement;
Form PTO/SB/08 w/ Notification of Reasons for Refusal;
2 Documents with 2 English Abstracts;
Check for \$920.00



COMMISSIONER OF PATENTS

Receipt is hereby acknowledged of the papers filed as indicated
in connection with the above-identified case.

SK/sg



 **COPY**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

December 2, 2005

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. A copy of each non-U.S. document is enclosed herewith.

Each listed document was cited in a communication from a foreign patent office. These documents are cited in the Notification of Reason(s) for Refusal mailed October 25, 2005 of the corresponding Japanese application in the present application. A copy of the Notification of Reason(s) for Refusal is also attached. Please note that one of the cited references, JP 11-54705A was previously filed with the Information Disclosure Statement on March 7, 2005.

Information Disclosure Statement
Application No. 10/622,614
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If there are any fees due in connection with the filing of this paper, please charge Deposit
Account No. 50-2866.

Respectfully submitted,
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP



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Enclosure: PTO/SB/08;
2 Documents with 2 English Abstracts; and
Notification of Reasons for Refusal



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known

Application Number	10/622,614
Confirmation Number	2630
Filing Date	July 21, 2003
First Named Inventor	Kenichi WATANABE et al.
Art Unit	2826
Examiner Name	Alexander O. Williams
Attorney Docket Number	030877

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			
		US			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
	AA	JP	2000-269219	A	09/29/2000	FUJITSU LTD.	Abstract
	AB	JP	2003-086590	A	03/20/2003	MATSUSHITA ELECTRIC IND. CO. LTD.	Abstract

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶

Examiner Signature

Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to indicate here if English language Translation is attached.